

<b>Notice of References Cited</b>	Application/Control No. 10/697,161	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Pierre-Louis Desir	Art Unit 2681	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0120494	06-2004	Jiang et al.	379/210.01
	B	US-6,574,335	06-2003	Kalmanek et al.	379/386
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

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